



Attorney's Docket No.: 10559-879001/P17481

*LFW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yan Borodovsky  
Serial No.: 10/688,306  
Filed : October 17, 2003  
Assignee : Intel Corporation  
Title : COMPOSITE PRINTING

Art Unit: 2851  
Examiner: Rodney Fuller

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and documents listed on form PTO-1449.

Copies of the U.S. patents/publications are not being provided per the waiver posted on the PTO website.

Kindly accept this Information Disclosure Statement under Rule 97(c)(2). The rule 17(p) certification fee of \$180 is enclosed.

07/13/2005 BABRAHA1 00000014 10688306

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July 6, 2005

Date of Deposit

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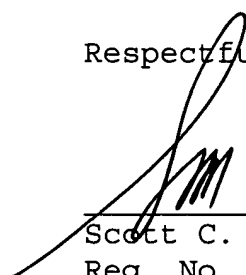
The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Please apply any additional charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 6, 2005

  
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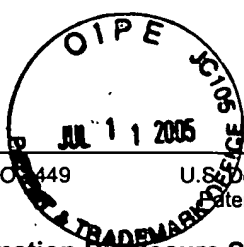
Respectfully submitted,

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<b>Substitute Form PTO-1449</b> (Modified)  <b>Information Disclosure Statement</b> <b>by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	<b>U.S. Department of Commerce</b> <b>Patent and Trademark Office</b>	<b>Attorney's Docket No.</b> 10559-879001	<b>Application No.</b> 10/688,306
	<b>Applicant</b> Yan Borodovsky		
	<b>Filing Date</b> October 17, 2003	<b>Group Art Unit</b> 2851	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,759,744	June 2, 1998	Brueck, et al.			
	AB	5,415,835	May 16, 1995	Brueck, et al.			
	AC	5,328,807	July 12, 1994	Tanaka, et al.			
	AD	6,553,562	April 22, 2003	Capodieci, et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	EP 0855623	July 29, 1998	EP				
	AM	WO 98/32054	July 23, 1998	PCT				
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	Ishibashi, et al., "AFM Lithography Combined with Optical Lithography", <i>IEEE Microprocesses and Nanotechnology Conference 2000</i> , pp. 192-193 (July 2000).
	AR	Martin, et al., "Ordered Magnetic Nanostructures: Fabrication and Properties", <i>J. Magnetism and Magnetic Materials</i> , 256(1-3):449-501 (January 2003).
	AS	
	AT	

<b>Examiner Signature</b>	<b>Date Considered</b>
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	